



Application No. 10/735,216  
Amendment Dated November 14, 2005  
Reply to Office Action of August 12, 2005

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

DORDI et al.

Application No.: 10/735,216

Filed: December 12, 2003

For: METHOD AND APPARATUS FOR  
MATERIAL DEPOSITION IN  
SEMICONDUCTOR FABRICATION

Examiner: Nguyen, Thanh T.

Art Unit: 2813

Docket No.: LAM2P458

Date: November 14, 2005

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 14, 2005.

Signed: \_\_\_\_\_

Kenneth D. Wright

**AMENDMENT**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is submitted in response to the Office Action dated August 12, 2005, and within the three-month period for reply extending to November 14, 2005. Please enter the following amendments and remarks.

**Amendments to the Specification** begin on page 2 of this Amendment.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this Amendment.

**Remarks/Arguments** begin on page 10 of this Amendment.